

<b>Notice of References Cited</b>	Application/Control No. 10/066,189	Applicant(s)/Patent Under Reexamination MLEJNEK, MICHAL	
	Examiner Arnel C. Lavarias	Art Unit 2872	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,298,312	03-1994	Oyama et al.	428/216
	B	US-6,187,445	02-2001	Ito et al.	428/426
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	NONE				
	O					
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	NONE
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